



PATENT

UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: HEIMES ET AL 1
SERIAL NO: 10/607,626
FILED: JUNE 27, 2003 GROUP: 3723
TITLE: PROCESS FOR MACHINING A WAFER-LIKE WORKPIECE

SUBMISSION OF INFORMATION DISCLOSURE STATEMENT
OF DR. WOLFGANG STAUDACHER

Mail Stop: Non-fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants wish to bring to the attention of the Patent Examiner the attached Information Disclosure Statement, duly signed by Dr. Wolfgang Staudacher, and the 1 reference listed on the enclosed Form PTO-1449 and attached thereto. These references were cited in the Office Action of the German Patent and Trademark Office.

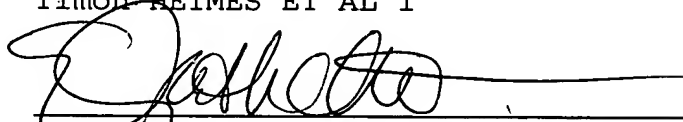
It is respectfully requested that the foregoing Information Disclosure Statement be incorporated into the official file of the present patent application.

Since this Information Disclosure Statement is being filed prior to a first Office Action, it is believed that no fee is due. However, if it is determined that a fee is due, the

Commissioner is hereby authorized to charge, or to credit any over payment, to our Deposit Account Number 03-2468.

It is respectfully requested that this Information Disclosure Statement be considered and placed into the application file.

Respectfully submitted,
Timon HEIMES ET AL 1



Allison C. Collard, Reg. No. 22,532
Edward R. Freedman, Reg. No. 26,048
Elizabeth C. Richter, Reg. No. 35,103
Attorneys for Applicants

COLLARD & ROE, P.C.
1077 Northern Boulevard
Roslyn, New York 11576
(516) 365-9802

Enclosures: 1) IDS of Dr. Wolfgang Staudacher
 2) PTO-form 1449
 3) 1 Ref.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: COMMISSIONER OF PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450 on MARCH 17, 2004.



Maria Guastella



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

HEIMES ET AL.-1

Serial Number:

10/607,626

Group Art Unit: 3723

Filed:

JUNE 27, 2003

For: PROCESS FOR MACHINING A WAFER-LIKE WORKPIECE

Information Disclosure Statement

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir or Madam:

I, Wolfgang Staudacher, associated with the preparation and prosecution of the above-identified application, residing at Seebauerstraße 4, 81735 München, Germany, wish to call the attention of the Patent Examiner to the references enumerated on the enclosed PTO Form-1449.

I believe the documents enumerated on the enclosed Form PTO-1449 and attached thereto, are cited in the enclosed application as well as in the Office Action of the German Patent and Trademark Office and may be material to the examination of the application.

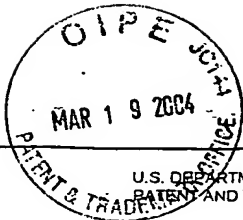
Therefore, it is respectfully requested that the foregoing Information Disclosure Statement be considered by the Examiner and incorporated into the file of this application.

I wish to comment as follows concerning the prior art references enumerated on PTO Form-1449:

For JP 05 177 534 A an English Patent Abstract of Japan is enclosed (cited in the application as well as in the German Office Action).

Signed this 7th day of July, 2003.


.....
Dr. Wolfgang Staudacher

FORM PTO-1449
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.: Heimes et alSERIAL NO. 10/607 626

LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

APPLICANT: Heimes et al. - 1FILING DATE: 6/27/03GROUP: 3723

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR		<u>English Patent Abstract of Japan</u>
			<u>corresponding to JP - 05477534</u>
	AS		
	AT		

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.